Notice of Allowability	Application No.	Applicant(s)	
	10/600,724	YI, SANG-DON	
	Examiner	Art Unit	
	Anh D. Mai	2814	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to <u>amendment filed 11/18/2004 and the telephone interview on 12/10/2004.</u>			
2. The allowed claim(s) is/are <u>7-28</u> .			
3. A The drawings filed on 20 June 2003 are accepted by the Examiner.			
 4.			
attached Examiner's comment regarding REQUIREMENT	FOR THE DEPOSIT OF BIOLOGIC.	AL MATERIAL.	
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal P 6. ☐ Interview Summary Paper No./Mail Dat 7. ☒ Examiner's Amendr 8. ☒ Examiner's Stateme 9. ☐ Other	(PTO-413), te ment/Comment	

DETAILED ACTION

Status of the Claims

1. Amendment filed November 18, 2004 has been entered. Claims 7, 14-17, 19-23, 26 and 27 have been amended. Claim 28 has been added. Claims 7-28 are pending.

EXAMINER'S AMENDMENT

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Anthony P. Onello, Jr., Reg. No. 38,572 on December 10, 2004.

The application has been amended as follows:

In the Claims:

Claim 7, step d), line 10, after: "the N-well" insert -- and the pad insulating film, --.

Allowable Subject Matter

- 3. Claims 7-28 are allowed.
- 4. The following is an examiner's statement of reasons for allowance: prior art of record fails to teach a method of manufacturing an SOI wafer in the combination of the limitations as claimed including: the pad insulating film is formed prior to the implantation to form the wells and still remains on the first semiconductor wafer during the pre-bonding step.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Anh D. Mai whose telephone number is (571) 272-1710. The examiner can normally be reached on 9:00AM-5:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on (571) 272-1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Anh D. Mai

December 10, 2004